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Current Developments in Lens Design and Optical Engineering XIII

**R. Barry Johnson
Virendra N. Mahajan
Simon Thibault**
Editors

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Introduction

Our conference on Current Developments in Lens Design and Optical Engineering attracted a large number of high-quality papers that ranged from optical design and analysis to design optimization, fabrication, solid state lighting, tunable lenses, and optical thin films. Thirty-two oral papers were presented in nine sessions over a period of two-and-a-half days. Two of these papers were in the invited category. Eleven papers were discussed in a poster session. Our conference continues to be an excellent venue for presentation and discussion of a very diverse range of lens design and optical engineering research and development activities.

R. Barry Johnson
Virendra N. Mahajan
Simon Thibault